



Dear Sir:

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

	Applicant: Serial No. Filed:		Ryoichi Mukai) I hereby certify that this paper is being deposited with the United States Postal Service as FIRST-CLASS mail in an envelope addressed to: Mail Stop AF, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313 450, on this date.) November 16, 2006 Date Registration No. 47,954
			10/058,662	
			January 28, 2002	
	Conf. 1	No.	3822	F-CLASS.WCM) Appr. February 20, 1998 Attorney for Applicant
	For: POLYCRYSTALLINE STRUCTURE FILM AND METHOD OF MAKING SAME		CTURE FILM AND)))
	Art Un	it:	1771))
	Exami	ner:	Piziali, Andrew T.	Ć
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(29)	Mail Stop AF Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450			

In response to the final Office Action mailed August 16, 2006, please enter the following amendments to the above-identified Application: